



03500.017483.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
YUKIO CHIBA)	Examiner: Not Yet Assigned
Application No.: 10/642,231)	Group Art Unit: Not Yet Assigned
Filed: August 18, 2003)	
For: IMAGE PROCESSING)	
APPARATUS AND METHOD)	
THEREFOR)	October 29, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are not enclosed, as all are U.S. patents or published U.S. patent applications.

The Examiner's attention is also directed to the following U.S. application:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT</u>
10/369,544	February 21, 2003	2621

A copy of the cited application is enclosed.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicant

Registration No. 44,063

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200

FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (See several sheets if necessary)				ATTY DOCKET NO. 03500.017483.		APPLICATION NO. 10/642,231	
APPLICANT YUKIO CHIBA							
FILING DATE August 18, 2003						GROUP N/Y/A	

U.S. PATENT DOCUMENTS							
EXAMINER	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	US 2002/0090142A1	7/11/02	Igarashi et al.	382	246	12/19/01	
	US 2002/0122599A1	9/5/02	Igarashi et al.	382	239	2/12/02	
	US 2002/0164080A1	11/7/02	Igarashi et al.	382	233	2/26/02	
	US 2003/0058143A1	3/27/03	Chiba et al.	341	67	9/18/02	
	US 2003/0118240A1	6/26/03	Satoh et al.	382	239	11/19/02	
	6,603,413	8/5/03	Igarashi et al.	341	67	2/7/02	

FOREIGN PATENT DOCUMENTS							
EXAMINER	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT	

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)		

EXAMINER	DATE CONSIDERED
----------	-----------------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.